



ELECTRONIC COPY

LG640443187
Report verification at igi.org



June 27, 2024

IGI Report Number **LG640443187**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **5.59 X 5.48 X 3.73 MM**

GRADING RESULTS

Carat Weight **1.05 CARAT**

Color Grade **G**

Clarity Grade **VVS 1**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

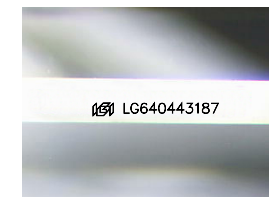
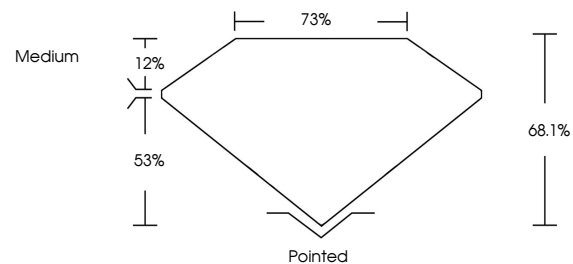
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG640443187**

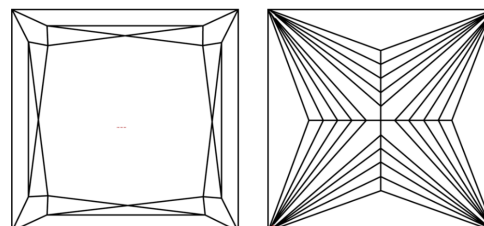
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

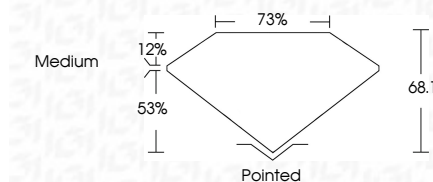
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| | | | | |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



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IGI Report No. **LG640443187**
PRINCESS CUT

5.59 X 5.48 X 3.73 MM

Carat Weight **1.05 CARAT**

Color Grade **G**

Clarity Grade **VVS 1**

Depth **68.1%**

Table **75%**

Girdle **Medium**

Culet **Pointed**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

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Type IIa